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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: LEE, Ho  
Assignee: SAMSUNG ELECTRONICS CO., LTD.  
Title: CHEMICAL VAPOR DEPOSITION APPARATUS  
Application No.: 10/750,023 Filing Date: December 31, 2003  
Examiner: Unknown Group Art Unit: 1734  
Docket No.: AB-1350 US Confirmation No.: 9344

San Jose, California  
February 18, 2005

Mail Stop Amendment  
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**INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR § 1.97(b) WITH  
CERTIFICATION UNDER 37 CFR § 1.97(e)(1)**

Dear Sir:

Pursuant to 37 CFR § 1.56, § 1.97 and § 1.98, the documents listed on the accompanying form PTO-1449 are called to the attention of the Examiner for the above patent application. Copies of these documents are enclosed. The documents were first cited in an Office Action dated January 25, 2005 by the Korean Patent Office in a corresponding Korean Patent Application No. 10-2003-0023398.

Citation of these documents shall not be construed as:

1. an admission that the documents are necessarily prior art with respect to the instant invention;
2. a representation that a search has been made, other than as described above; or
3. an admission that the information cited herein is, or is considered to be material to patentability as defined in § 1.56(b).

The undersigned hereby certifies in accordance with § 1.97(e)(1) that each item of information contained in this Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

MacPherson Kwok Chen & Heid  
LLP  
1762 Technology Drive  
Suite 226  
San Jose, CA 95110  
Telephone: (408) 392-9250  
Facsimile: (408) 392-9262

**Statement under 37 C.F.R. §1.704(d)**

Each item of information contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart application and this communication was not received by any individual designated in § 1.56(c) more than 30 days prior to the filing of the Information Disclosure Statement.

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**EXPRESS MAIL LABEL NO.**

**EV 552 910 558 US**

Respectfully submitted,



David W. Heid  
Attorney for Applicant  
Reg. No. 25,875

U.S. Department of Commerce, Patent and Trademark Office				Atty. Docket No.		Serial No.		
				AB-1350 US		10/750,023		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)				Applicant(s)				
				LEE, Ho				
				Filing Date		Group		
				12/31/2003		1734		
U.S. Patent Documents								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA							
	AB							
	AC							
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
Foreign Patent Documents								
							Translation	
		Document	Date	Country	Class	Subclass	Yes	No
	AL	2-73624	03/13/1990	Japan				X
	AM							
	AN							
	AO							
	AP							
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
	AQ	Patent Abstracts of Japan, Publication No. 02-073624, 03/13/1990						
	AR							
Examiner			Date Considered					
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.</p>								